

KOREAN PATENT ABSTRACTS (KR)

REGISTERED PATENT PUBLICATION

TO COO TALL BOOK (24) Registration Date: 24 August 1998 (22) Application Date: 10 March 1995

(21) Application No.: 10-1995-004959 (43) Publication Date: 28 October 1996

(51) IPC Code: H01L 21/31

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(11) Registration No.: 0161397 (Patent)

(65) Publication No.: 1996-035876

(54) Title of the Invention:

Method of Fabricating Capacitor for Use in Semiconductor Device

(57) Abstract:

Provided is a method of fabricating a capacitor. This method includes forming a lower electrode using a TiN or WN layer on a semiconductor substrate, preprocessing the lower electrode using p-NH₃, forming a dielectric layer on the preprocessed lower electrode, and forming an upper electrode on the dielectric layer. With this method, a dielectric layer can be evenly and regularly formed on a lower electrode so as to prevent a local increase in a leakage current due to a current generated by an upper electrode.